

Notice of References Cited	Application/Control No. 10/784,666	Applicant(s)/Patent Under Reexamination TAKAMATSU ET AL.	
	Examiner Varsha A. Kapadia	Art Unit 2651	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,493,173	12-2002	Kim et al.	360/77.04
	B	US-2001/0030828	10-2001	Takaishi, Kazuhiko	360/78.14
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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